

033082M252

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Takahiro Nishibayashi

International Application No.: PCT/JP2003/014176

International Filing Date: November 7, 2003

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: INSULATION FILM FORMING DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicant is enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the specification and in the International Search Report being filed herewith. On the PTO-1449, documents AL and AM are cited from Applicant's specification. The rest come from the Search Report. Copies of all cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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By: 

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May 4, 2005

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M252	SERIAL NO. 107533932 <small>To Be Assigned</small>
	APPLICANT: Takahiro Nishibayashi	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	2002/0037462	3/28/02	Ogata et al.			
	AB	5,762,745	6/9/98	Hirose			
	AC						
	AD						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AL	2000-138213	5/16/00	Japan			Abstract	
	AM	2003-100621	4/4/03	Japan			Abstract	
	AN	09-129526	5/16/97	Japan			Abstract	
	AO	2002-064044	2/28/02	Japan			Abstract	
	AP	2002-329717	11/15/02	Japan			Abstract	

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	Semiconductor FPD World Zokango, "02 Saishin Hando tai Process Gijutsu-Technology & Equipment", Vol. 20, No. 15, pp. 188-189,
	AR	

EXAMINER:	DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	